



Docket No.:0756-7293

1FW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

THE PATENT application of)
Koichiro TANAKA, et al.)
Serial No. 10/827,449) Group Art Unit: 2874
Filed: April 20, 2004) Examiner: Michael Stahl
For: BEAM HOMOGENIZER, LASER)
IRRADIATION APPARATUS, AND METHOD FOR)
MANUFACTURING SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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Henry L. Reese

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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